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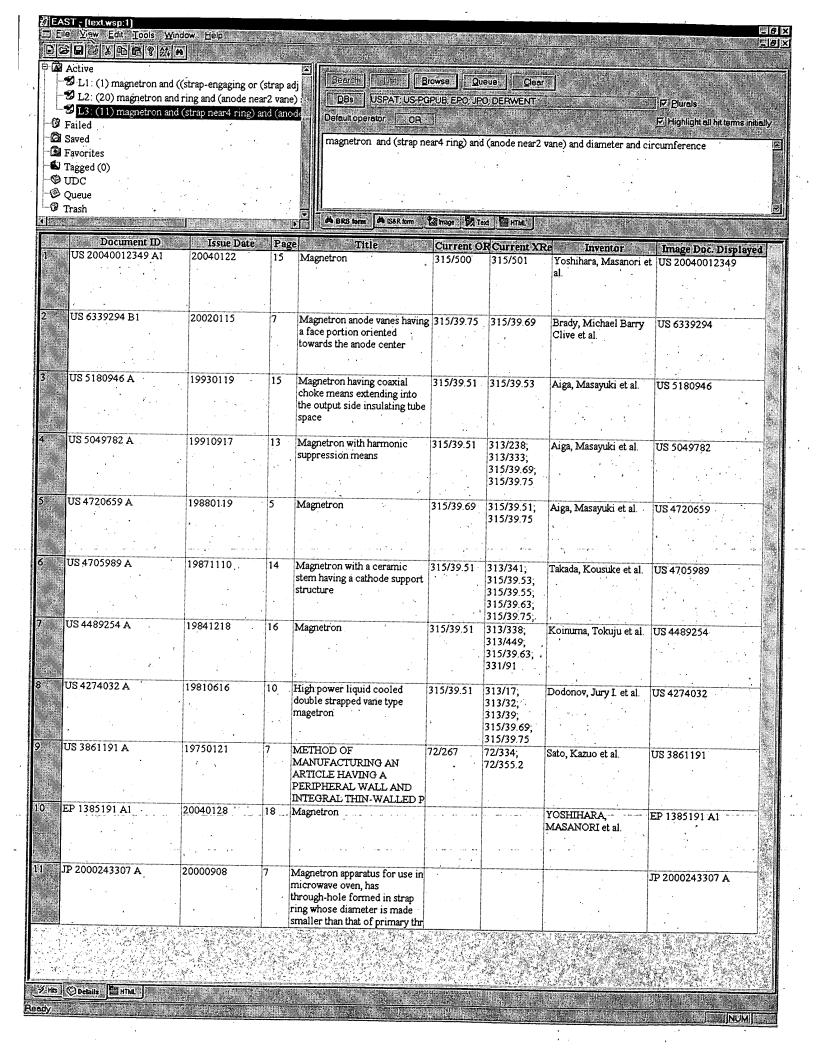
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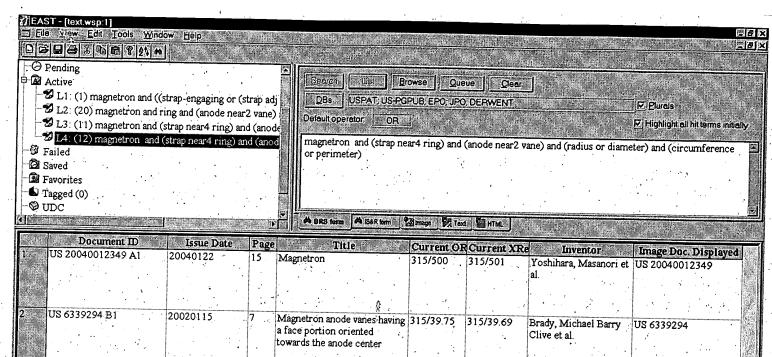
USPAT, US-POPUB, EPO, JPO, 2004/04/28

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US 4000001249 Al   20040122   15   Magnetron   315/500   315/501   Pothibira, Massayori et   US 2004001249		Document ID	Issue Date	Pag	ge Title	Current C	D Current V		
US 5180946 A	1	US 20040012349 A1	20040122			315/500	215/501		
US 6339294 B1   20020115   7   Magnetron anode varies/having   315/39.75   315/39.69   Briefy, Michael Barry   US 6339294   Clive et al.				٠ .		313/300	10001		et US 20040012349
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A lace portion or reinted cowards the anode center   Clive et al.	2	US 6339294 B1	20020115	. 7	Magnetron anode vanes having	315/39.75	315/39.69	Brady, Michael Barry	IIS 6330204
19930119   15   Magnetron having counsil choke means extending into the couplet side ministing into the couplet side into the				1	a face portion oriented				08 0339294
Chicker means extending into the output side insulating tube space					towards the anode center				8
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Chicker means extending into the output side insulating tube space	3	US 5180946 A	10020110	1.6	-				
the output side installating tube space  4 US 5049782 A 19910917 13 Magnetron with harmonic suppression means 1313/39 51, 313/238, 313/333, 313/333, 313/333, 313/333, 315/39 69, 315/39 75  5 US 4720659 A 19880119 5 Magnetron 315/39 69 315/39 73 Aga, Masayuki et al. US 4720659 US 4705989 A 19871110 14 Magnetron with a ceramic stern having a cathode support structure stern having a cathode support structure 315/39 51, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 53, 315/39 54			19930119	13	Magnetron having coaxial	315/39.51	315/39.53	Aiga, Masayuki et al.	US 5180946
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US 5049782 A   19910917   13   Magnetron with harmonic suppression means   315/39.51   313/238, 313/39.69   315/39.75   315/39.75   315/39.69   315/39.75   315/				* .	the output side insulating tube				
September   Suppression means   Sissay   Sissa					space				*
Suppression means   313/333   315/39.69   315/39.69   315/39.75   Alga, Massyuki et al.   US 4720659	4	US 5049782 A	19910917	13	Magnetron with harmonic	215/20 51	213/030		
Section   Sect						10.29.01		Aiga, Masayuki et al.	US 5049782
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US 4720659 A				1.7				The second section of	
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315/39.75   313/39.51   313/341   Takada, Kousuke et al. US 4705989   315/39.51   313/39.53   315/39.53   315/39.53   315/39.53   315/39.53   315/39.53   315/39.53   315/39.53   315/39.75   315/39	2	US 4/20659 A	19880119	. 5	Magnetron	315/39.69	315/39.51	Aiga Masazaiki et cl	IIS 4720650
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19810818   19810818   19810818   Microwave magnetron-type device   315/39.51   313/338; 331/91   315/39.63; 331/91   315/39.63; 331/91   315/39.51   315/39.71   Dodonov, Jury L   2000000, Jury L   20000000, Jury L   20000000000000000000000000000000000			***************************************				315/39.63;	1	
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WS 4284924 A   19810818   Microwave magnetron-type device   315/39.51   315/39.71   Dodonov, Jury L		* * * * * * * * * * * * * * * * * * *							
US 4284924 A   19810818									
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